

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re patent application of:

Naoki Abe

Confirmation No. 8684

Serial No. 10/749,518

Group Art Unit: 2167

Filed: January 2, 2004

Examiner: Timblin, Robert M.

For: **RESOURCE-LIGHT METHOD  
FOR OUTLIER DETECTION**

Box AF  
Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT UNDER 37 C.F.R. § 1.116**

Sir:

In response to the Office Action mailed December 12, 2006, please amend the above-identified patent application as follows:

**Listing of the Claims** begins at page 2 of this paper.

**Remarks** begin at page 10 of this paper.